Electronic Acknowledgement Receipt				
EFS ID:	4598539			
Application Number:	09648111			
International Application Number:				
Confirmation Number:	5562			
Title of Invention:	Method of patterning a metal layer in a semiconductor device			
First Named Inventor/Applicant Name:	Kwang-Jo Hwang			
Correspondence Address:	Birch Stewart Kolasch & Birch LLP - PO BOX 747 - Falls Church VA 22040-0747 US 703 205-8000 -			
Filer:	Esther Hyeri Chong/Hannah White			
Filer Authorized By:	Esther Hyeri Chong			
Attorney Docket Number:	3430-0131P			
Receipt Date:	12-JAN-2009			
Filing Date:	25-AUG-2000			
Time Stamp:	18:05:10			
Application Type:	Utility under 35 USC 111(a)			
Payment information:				

yes

\$810

Deposit Account

Submitted with Payment

Payment was successfully received in RAM

Payment Type

KAW CONTINUATION NUMBER		3445	3445				
Deposit Account		022448	022448				
Authorized User							
Charge any Charge any	ne USPTO is hereby authorized to cl Additional Fees required under 37 C.F. Additional Fees required under 37 C.F.	R. Section 1.16 (National applic R. Section 1.17 (Patent applicat	ation filing, search, and exar ion and reexamination proc	mination fees)		
File Listing:	Additional Fees required under 37 C.F.	R. Section 1.19 (Document sup	ply fees)				
Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.		
		rceamend.pdf	640294	yes	17		
1			7e1193383072fcb2d834b31585350873c84 27b7b				
	Multip	art Description/PDF files i	n .zip description				
Document Descrip		scription	Start	End			
	Miscellaneous Incoming Letter Request for Continued Examination (RCE)		1	1			
			2	2			
	Miscellaneous Inco	3	3				
	Amendment Submitted/Entere	4	4				
	Claims Applicant Arguments/Remarks Made in an Amendment		5	11			
			12	17			
Warnings:							
Information:							
2	Fee Worksheet (PTO-06)	fee-info.pdf	30209	no	2		
	,		6dde3a92ef0ec43a3680f79315a5bdfex3e3 364d				
Warnings:							
Information:							
		Total Files Size (in byte	es): 67	70503			

3445

RAM confirmation Number

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-[d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.